

LECTURE 3: ADDITIONAL NANOMECHANICS INSTRUMENTATION COMPONENTS

Outline :

NANOMECHANICS ART FROM HOLLAND	2
LAST TIME : THE FORCE TRANSDUCER: <i>How can we measure such tiny forces?</i>	3
TRANSDUCER (SPRING CONSTANT) CALIBRATION	4
MECHANOTRANSDUCTION EXAMPLES.....	5-6
<i>Mapping the mechanical pulse of single cardiomyocytes</i>	5
<i>Intracellular calcium waves in 2D bone cell networks as a single cell is loaded</i>	6
HIGH RESOLUTION DISPLACEMENT DETECTION : <i>Optical lever beam deflection technique</i>	7
HIGH RESOLUTION DISPLACEMENT CONTROL : <i>How can we move an object one nanometer at a time?</i>	8
PIEZOELECTRICITY	9
PIEZO TUBE SCANNERS.....	9

Objectives: To describe the function of other instrumentation components necessary for nanomechanical experiments; lasers and piezos.

Readings: Course Reader Document 9

Multimedia : Listen to *Lipid Bilayers* podcast : <http://web.mit.edu/cortiz/www/Nanonewton.html>

NANOMECHANICS ART FROM HOLLAND

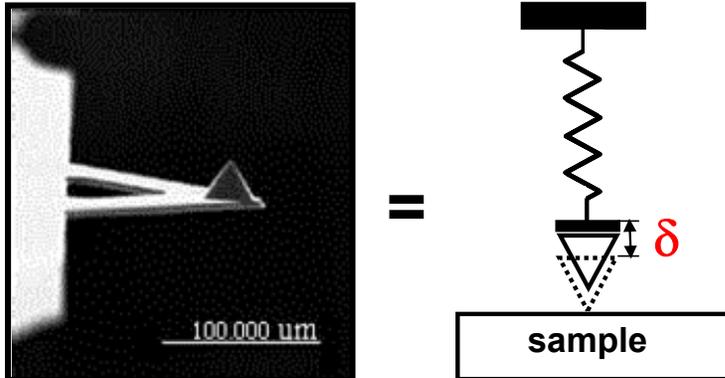
Jacob Kerssemakers Ph.D. Thesis U. Groningen (NL)

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LAST TIME : THE FORCE TRANSDUCER- HOW CAN WE MEASURE SUCH TINY FORCES?

i.e. nN ($=1 \cdot 10^{-9}$ N), even pN ($=1 \cdot 10^{-12}$ N) ! \rightarrow typical engineering structures are Newtons

microfabricated cantilever beams



force transducer- sensor device that responds to an external force where you can output and record that response

- **continuum beam theory** : reduces to Hooke's Law

$$F = \left[\frac{3EI}{L^3} \right] \delta \rightarrow F = k\delta$$

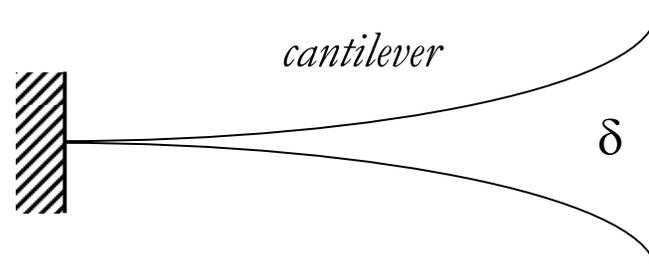
E= elastic modulus

I = moment of inertia of cross section

L= length of beam

k= cantilever spring constant

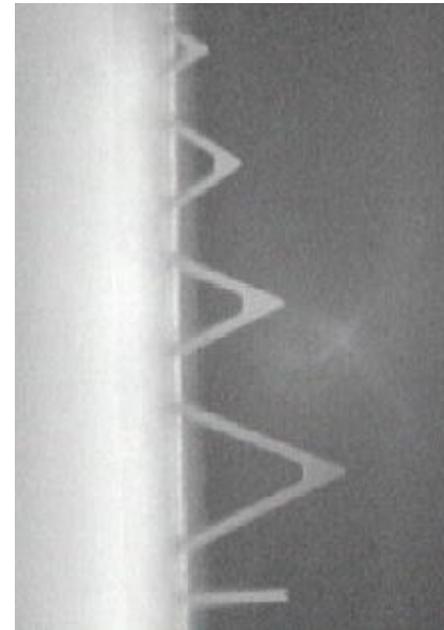
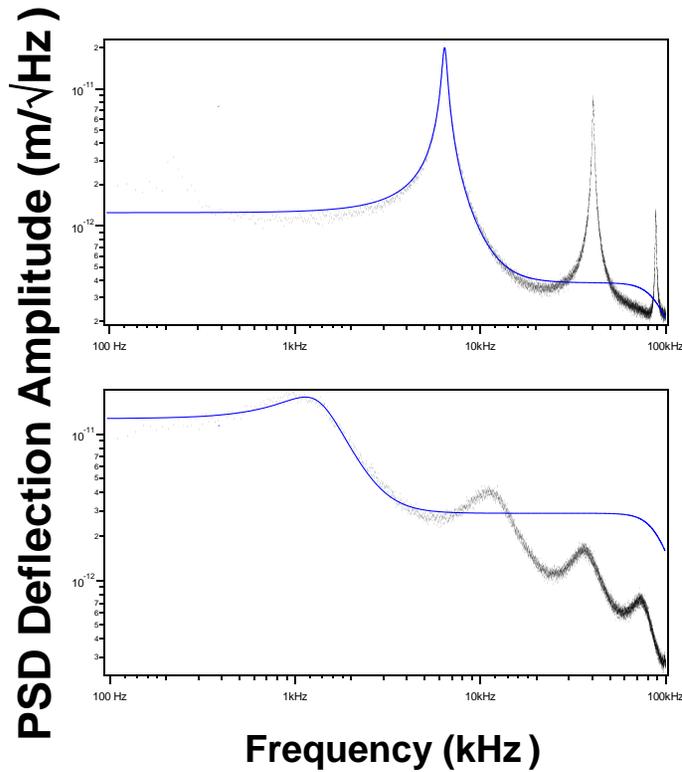
-**attachments** to nanosized probe tips at the ends of microfabricated cantilevers



-**limit of force detection given by thermal oscillations** \rightarrow can represent cantilever as driven, damped simple harmonic oscillator

TRANSDUCER (SPRING CONSTANT) CALIBRATION

- determine the relationship between the externally applied force and output signal to automatically convert to a force



$$A(\omega) = \text{amplitude of oscillations} = \frac{F/m}{\left[\left(\frac{k}{m} - \omega^2 \right)^2 + \left(\frac{\omega\beta}{m} \right)^2 \right]^{1/2}}$$

Derivation : Vibrations and Waves A.P. French, W. W. Norton and Company, NY 1971 eq. 4-13 and for more info see Shusteff, et al. Am. J. Phys. 74 (10) 2006 (Posted on the MIT Server, Optional Supplementary Resources)

MAPPING THE MECHANICAL PULSE OF SINGLE CARDIOMYOCYTES

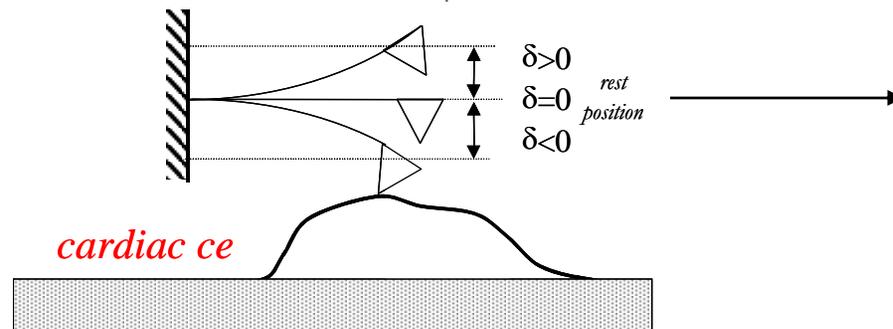


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I. **Individual cell** : sequences of high mechanical activity alternate with times of quietness, irregular beating which often last for minutes, active sequences were irregular in frequency and amplitude

Domke, et al. Eur. Biophys. J. (1999) 28, 179

II. **Group of cells**: "pulse mapping"

III. **Confluent layer of cells** : beat regularly in terms of frequency and amplitude, enormous stability of pulsing, cell are synchronized and coupled together : diverse pulse shapes due to macroscopic moving centers of contraction and relaxation

INTRACELLULAR CALCIUM WAVES IN 2D BONE CELL NETWORKS AS A SINGLE CELL IS LOADED *Guo, et al. MCB 3(3) 95-107 (2006)*

-Bone cells were cultured on micropatterned network with dimensions close to *in vivo*

-A force of ~ 61 nN was applied to an individual cell in the center with a microfabricated cantilever

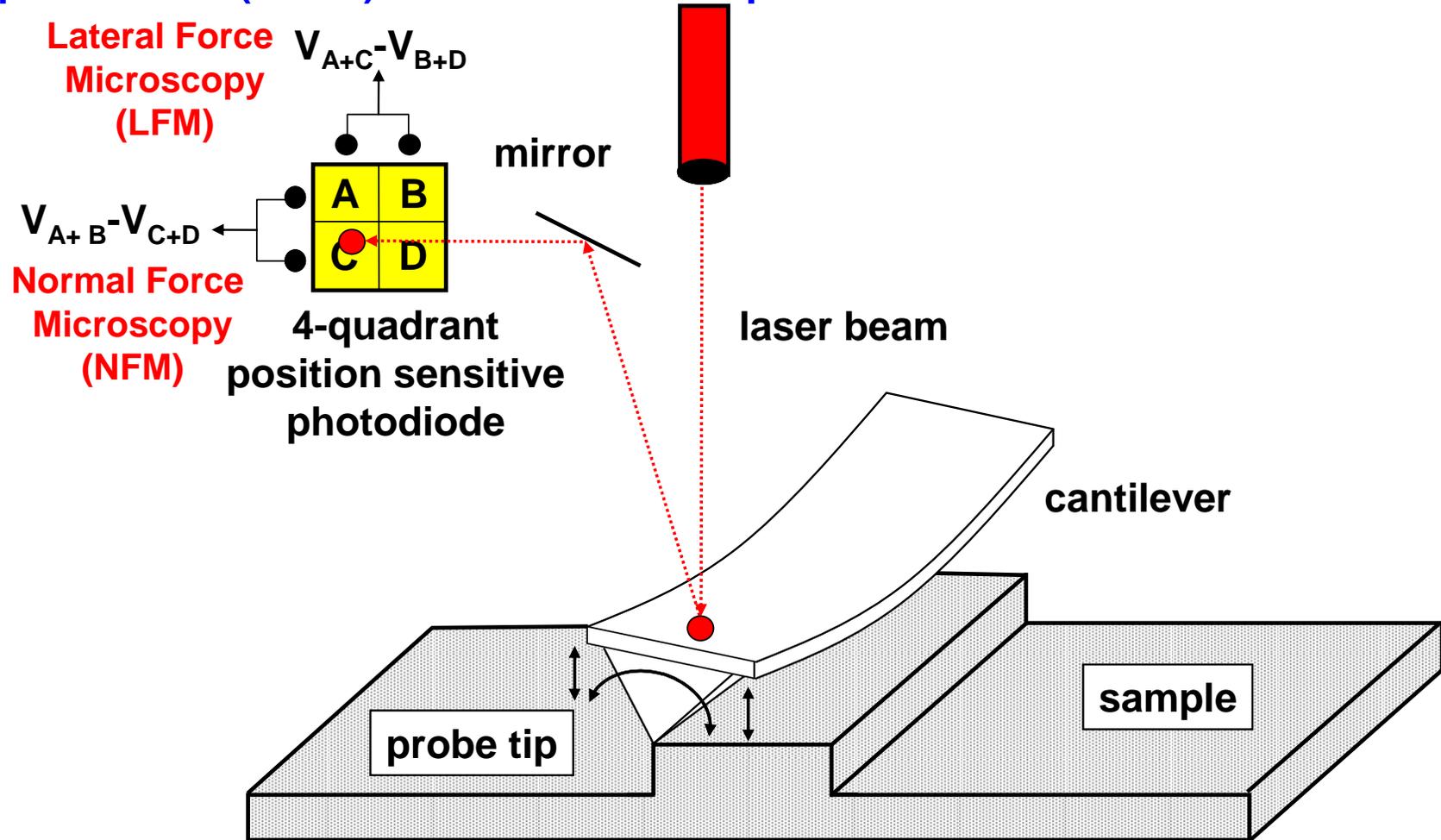
-Fluorescence time-lapsed images of intracellular calcium [Ca^{2+}] waves (signaling molecule)

-Some bone cells exhibit double response through signal propagation via different cell pathways, the ability to respond multiple times without a decrease in magnitude may play a role in memory of previous loading history

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Mechanotransduction - mechanism by which cells convert mechanical stimulus into chemical activity.

HIGH RESOLUTION DISPLACEMENT DETECTION : Optical Lever (Beam) Deflection Technique



HIGH RESOLUTION DISPLACEMENT CONTROL : How can we move an object one nanometer at a time?

"piezoelectric materials" : material which exhibits a change in dimensions in response to an applied voltage and conversely, the material develops an electric potential in response to an applied mechanical pressure

-generally made by sintering ceramic powder to yield polycrystalline material where each crystal has its own electrical dipole (randomly aligned)

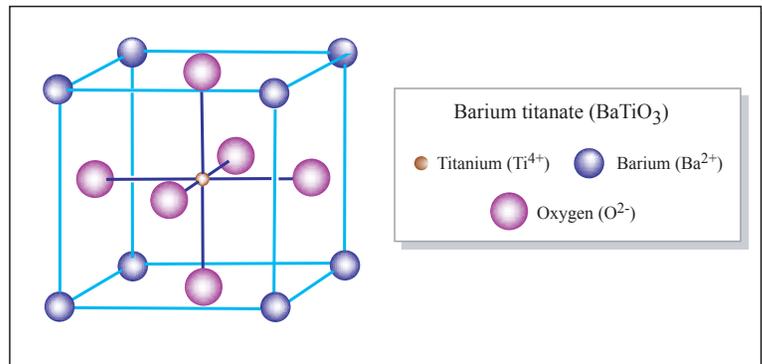
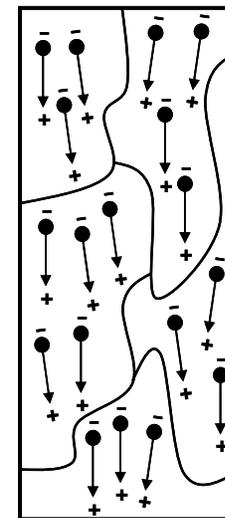
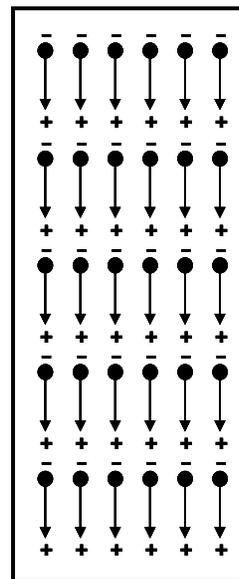
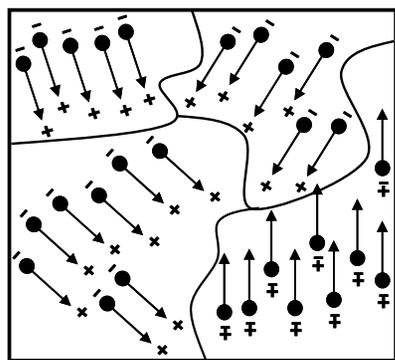


Figure by MIT OCW.



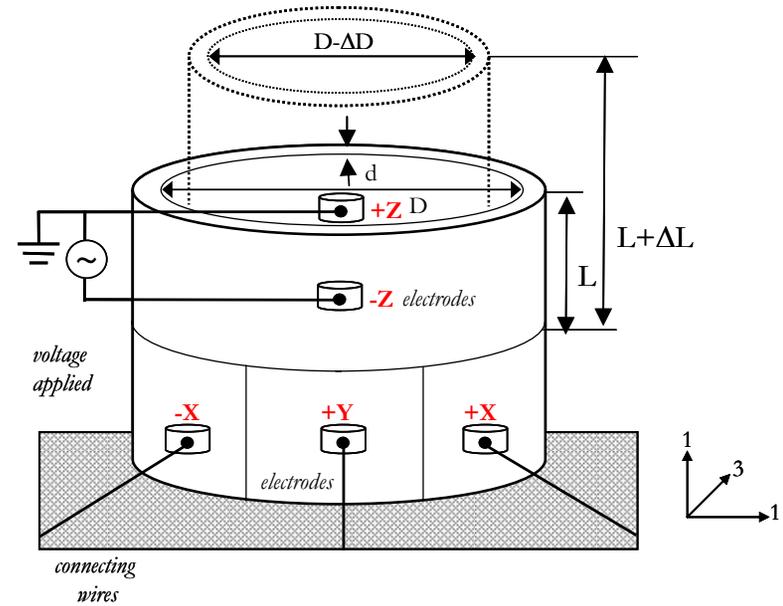
"Poling" : apply high electric field at high temperatures for a few hours to align the dipoles → remnant polarization after removal of electric field/cooling

PIEZOELECTRICITY

(*Digital Instruments "JV" PZT scanner)



Courtesy of Veeco Instruments. Used with permission.



PIEZO TUBE SCANNERS

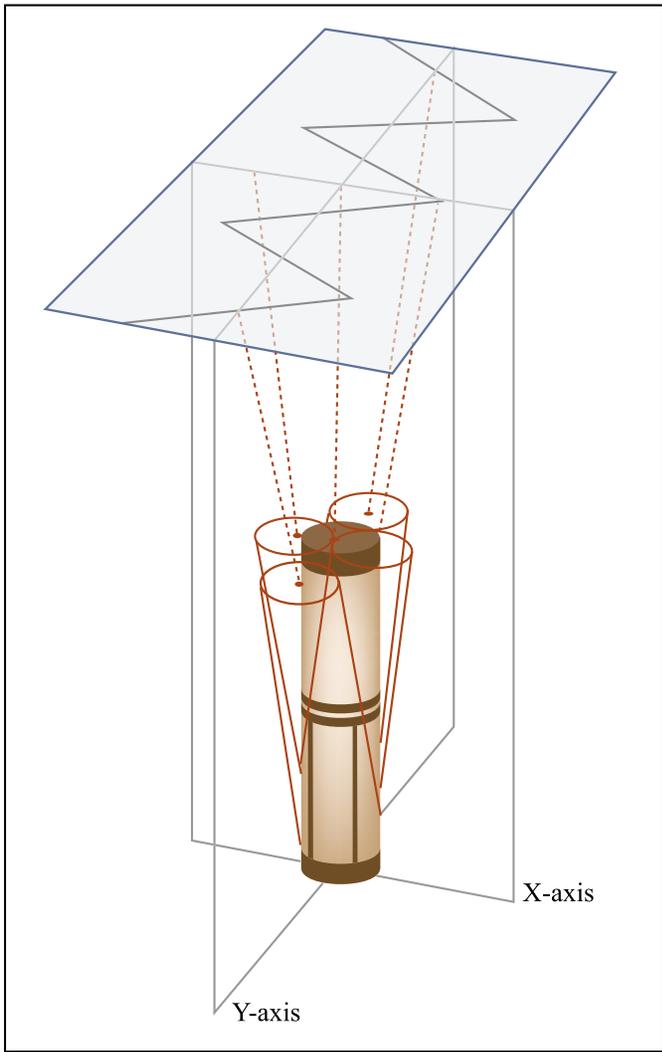


Figure by MIT OCW.